



Docket No.: 50432-096

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Calvin T. GABRIEL, et al. : Confirmation Number: 7774
Serial No.: 09/887,165 : Group Art Unit: 1763
Filed: June 25, 2001 : Examiner: George A. Goudreau
For: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED RESIST
POISONING

AMENDMENT

Mail Stop No Fee - Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendment and remarks are respectfully submitted in response to the Office Action dated October 3, 2002. This Office Action was never received, as detailed in the Petition For Reconsideration of Holding of Abandonment filed on even date herewith. This amendment comprises a complete response to the original Official Action of October 3, 2002 and entry of this amendment is respectfully requested.